ALEGRO (Advanced LinEar collider study GROup)

22-24 March 2023, Desy, Hamburg, Germany

Laser drivers for plasma accelerators

State-of-the-art and its relevance to collider development

Leonida Antonio GIZZI, CNR-INO, Pisa, Italy also at INFN, Pisa, Italy



Intense Laser Irradiation Laboratory

Istituto Nazionale di Ottica – Consiglio Nazionale delle Ricerche



CNR Campus in Pisa



Consiglio Nazionale delle Ricerche Area della Ricerca di Pisa

12.23

THE STREET



OUTLINE

- Intro on relevant laser needs and features
- Roadmap for laser driver development
- Short-medium term options
- Constraints and high efficiency options
- Engaged developments
- Summary

Grand challenges of laser-plasma technology

Aiming at extensive use of multiple (hundreds of) laser units at high average power



Cost, durability, energy efficiency, mass production of underlying laser components key to enable these developments.

Mature applications: X-ray imaging

X-ray imaging for compact, high resolution (phase contrast imaging) bio-medical diagnostics

Address some of the needs of large SR facility users



Needs next generation high repetition rate kW laser driver

Emerging applications: radiotherapy

LPA beams can meet specifications of advanced radiotherapy approaches

Laser-driven electron beams can provide ultra-high dose-rate to meet requirements of future "FLASH" radiotherapy with Very High Energy electrons (VHEE) in a compact size:



V. Favaudon et al., Sci Transl Med. 2014 Jul 16;6(245):245ra93

VHEE with Laser driven: Dosimetry



Proof of principle Multi-Field Radiation Therapy Very high energy electrons. (L.Labate et al. Sci Rep, 2020)

www.ino.it

Almost none of the 13000 radiotherapy linacs worldwide can deliver FLASH beams: a huge potential still to be addressed, with major R&D in RF accelerators and novel accelerators, including laser-driven LPA.

Needs next generation of high repetition rate <kW laser driver

Emerging applications: industry and security

High energy X-rays or neutron sources are being developed for industry and security



Industrial high temporal resolution X-ray imaging - C. M. Brenner et al, PPCF, 58 014039, (2015)



Laser driven neutron sources at Los Alamos

New high intensity laser based facility (80M GPB investment) to support science, technology, innovation and industry.



on for failure modes in vere and heavy metals such as steel



aspection of battery components. full-scale systems and fuel cells for ron-scale defects with micro CT



The Extreme Photonics Applications Centre, CLF, UK





Ultra high contrast, high resolution and high throughput biological mic **CT** imaging



cits in extreme o

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Moving to implementation of kW laser technology for users

L.A. Gizzi, 24 Mar 2023, Alegro Workshop, DESY, Hamburg, Germany

High intensity lasers: evolution

Major breakthrough following Chirped Pulse Amplification

Current laser technology developmentof CPA lasers [1] mainly driven by **extreme intensity** applications;

Laser-Plasma acceleration has developed along with progress in laser performance;

Recent LWFA-FEL demonstration [2] highlights the role of laser stability and control;

Need to focus on the technology required to achieve high-repetition rate at multi-joule (≈100 TW) scale [3], with high quality and enhanced control and stability;

Key role of industry to establish turn-key, high average/peak power ultrashort pulse technology;



D. Strickland and G. Mourou, "Compression of amplified chirped optical pulses." Optics communications 55, 447 (1985)
 W. Wang, K.Feng et al., Free-electron lasing at 27 nanometres based on a laser wakefield accelerator, <u>Nature</u> 595, 516–520 (2021)
 L.A. Gizzi et al., A viable laser driver for a user plasma accelerator, NIM A 909, 58 (2018); <u>https://doi.org/10.1063/1.4984906</u>
 J. W. Yoon et al., "Realization of laser intensity over 1023 W/cm2." Optica 8, 630-635 (2021), <u>https://doi.org/10.1364/OPTICA.420520</u>

LWFA: laser power and quality control

Progress in laser specs is key to the development o Laser Wakefield Acceleration



What laser driver specs for future LPAs

Rapidly evolving scenario for laser technologies relevant for plasma acceleration towards multi-stage accelerators design:

Pillars for a STRATEGY for laser drivers for plasma accelerators:

Ultrashort pulses (large bandwidth <50 fs) High Repetition rate (100 Hz – 50 kHz) High average power (kW -10s kW) High wall-plug efficiency (>10%)

• IFAST EU project on novel accelerator techniques just funded (Coordinated by CERN): https://ifast-project.eu/

EUROPEAN

HORIZ

2020

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- Task on "Lasers for Plasma Acceleration (LASPLA)"
 - Roadmap to foster delivery of industrial laser drivers for the plasma-based accelerator.
 - Networking among main laser lab working on LPA laser-driver R&D.

L.A. Gizzi, F. Mathieu, P. Mason, P P Rajeev, Laser drivers for Plasma Accelerators, in Félicie Albert et al, 2020 roadmap on plasma accelerators, 2021 New J. Phys. 23 031101, <u>https://doi.org/10.1088/1367-2630/abcc62</u>

Roadmap for laser driver development

Parto of the WP6: Novel Particle Accelerators Concepts and Technologies of i.FAST



Difast Innovation Fostering in Accelerator Science and Technology (I.FAST) coordinated by CERN https://ifast-project.eu/

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Average power

Current reqirement for LPA driver: PW-class system, with high repetition rate (≈kHz) Demanding high average power



Major effort required to fill the gap between existing and required laser technology



Relevant blocks of a laser driver

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Roadmap on LPA Laser Driver technology

Laser-driven plasma acceleration needs ultrashort, high power lasers with high average power

- Current industrial technology: ≈ Ti:Sa technology, pumped by flash-lamp pumped lasers
 - Robust, reliable industrial technology
- Mature technology: ≈ Ti:Sa technology, pumped by diodepumped lasers
 - Strong R&D effort in place (e.g HAPLS@ELI)
 - ≈ 3-5 years to go to first industrial LWFA demonstrator (e.g. Eupraxia) [1]
- Beyond TiSA: targeting higher wall-plug efficiency and rep. rate, kHz and beyond, stability, control (space, time, spectral);
 - 5-10 yrs for first efficient, multi-kW-scale demonstrator,
 - A strategy is needed to steer effort in the LPA laser driver direction: LASPLA





The L3-HAPLS at ELI Beamlines Research Center in the Czech Republic. Credit: ELI Beamlines*

R. Assmann et al., EuPRAXIA Conceptual Design Report, The European Physical Journal Special Topics 229, 3675–4284 (2020)
 C. Danson et al., Petawatt and exawatt class lasers worldwide High Power Laser Sci. and Eng. 7, e54 (2019)



The EuPRAXIA Project



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With the inclusion in ESFRI and the approval of the Preparatory Phase Project, EuPRAXIA must rapidly move from the conceptual design to a <u>viable</u> technical design of the laser driver.



R. W. Assmann, M. K. Weikum, T. Akhter, D. Alesini, A. S. Alexandrova, M. P. Anania, N. E. Andreev, I. Andriyash, M. Artioli, A. Aschikhin, T. Audet, A. Bacci, I. F. Barna, S. Bartocci, A. Bayramian, A. Beaton, A. Beck, M. Bellaveglia, A. Beluze, A. Bernhard, A. Biagioni, S. Bielawski, F. G. Bisesto, A. Bonatto, L. Boulton, F. Brandi, R. Brinkmann, F. Briquez, F. Brottier, E. Bründermann, M. Büscher, B. Buonomo, M. H. Bussmann, G. Bussolino, P. Campana, S. Cantarella, K. Cassou, A. Chancé, M. Chen, E. Chiadroni, A. Cianchi, F. Cioeta, J. A. Clarke, J. M. Cole, G. Costa, M. -E. Couprie, J. Cowley, M. Croia, B. Cros, P. A. Crump, R. D'Arcy, G. Dattoli, A. Del Dotto, N. Delerue, M. Del Franco, P. Delinikolas, S. De Nicola, J. M. Dias, D. Di Giovenale, M. Diomede, E. Di Pasquale, G. Di Pirro, G. Di Raddo, U. Dorda, A. C. Erlandson, K. Ertel, A. Esposito, F. Falcoz, A. Falone, R. Fedele, A. Ferran Pousa, M. Ferrario, F. Filippi, J. Fils, G. Fiore, R. Fiorito, R. A. Fonseca, G. Franzini, M. Galimberti, A. Gallo, T. C. Galvin, A. Ghaith, A. Ghigo, D. Giove, A. Giribono, L. A. Gizzi, F. J. Grüner, A. F. Habib, C. Haefner, T. Heinemann, A. Helm, B. Hidding, B. J. Holzer, S. M. Hooker, T. Hosokai, M. Hübner, M. Ibison, S. Incremona, A. Irman, F. Iungo, F. J. Jafarinia, O. Jakobsson, D. A. Jaroszynski, S. Jaster-Merz, C. Joshi, M. Kaluza, M. Kando, O. S. Karger, S. Karsch, E. Khazanov, D. Khikhlukha, M. Kirchen, G. Kirwan, C. Kitégi, A. Knetsch, D. Kocon, P. Koester, O. S. Kononenko, G. Korn, I. Kostyukov, K. O. Kruchinin, L. Labate, C. Le Blanc, C. Lechner, P. Lee, W. Leemans, A. Lehrach, X. Li, Y. Li, V. Libov, A. Lifschitz, C. A. Lindstrøm, V. Litvinenko, W. Lu, O. Lundh, A. R. Maier, V. Malka, G. G. Manahan, S. P. D. Mangles, A. Marcelli, B. Marchetti, O. Marcouillé, A. Marocchino, F. Marteau, A. Martinez de la Ossa, J. L. Martins, P. D. Mason, F. Massimo, F. Mathieu, G. Mavnard, Z. Mazzotta, S. Mironov, A. Y. Molodozhentsev, S. Morante, A. Mosnier, A. Mostacci, A. -S. Müller, C. D. Murphy, Z. Najmudin, P. A. P. Nghiem, F. Nguyen, P. Niknejadi, A. Nutter, J. Osterhoff, D. Oumbarek Espinos, J. -L. Paillard, D. N. Papadopoulos, B. Patrizi, R. Pattathil, L. Pellegrino, A. Petralia, V. Petrillo, L. Piersanti, M. A. Pocsai, K. Poder, R. Pompili, L. Pribyl, D. Pugacheva, B. A. Reagan, J. Resta-Lopez, R. Ricci, S. Romeo, M. Rossetti Conti, A. R. Rossi, R. Rossmanith, U. Rotundo, E. Roussel, L. Sabbatini, P. Santangelo, G. Sarri, L. Schaper, P. Scherkl, U. Schramm, C. B. Schroeder, J. Scifo, L. Serafini, G. Sharma, Z. M. Sheng, V. Shpakov, C. W. Siders, L. O. Silva, T. Silva, C. Simon, C. Simon-Boisson, U. Sinha, E. Sistrunk, A. Specka, T. M. Spinka, A. Stecchi, A. Stella, F. Stellato, M. J. V. Streeter, A. Sutherland, E. N. Svystun, D. Symes, C. Szwaj, G. E. Tauscher, D. Terzani, G. Toci, P. Tomassini, R. Torres, D. Ullmann, C. Vaccarezza, M. Valléau, M. Vannini, A. Vannozzi, S. Vescovi, J. M. Vieira, F. Villa, C. -G. Wahlström, R. Walczak, P. A. Walker, K. Wang, A. Welsch, C. P. Welsch, S. M. Weng, S. M. Wiggins, J. Wolfenden, G. Xia, M. Yabashi, H. Zhang, Y. Zhao, J. Zhu & A. Zigler **EuPRAXIA Conceptual Design Report** The European Physical Journal Special Topics 229, 3675-4284 (2020);

https://doi.org/10.1140/epist/e2020-000127-8



The EuPRAXIA Project



A New European High-Tech Research Facility Delivering Frontier Science



Shrink down the facility size





Producing particle and photon pulses to support several urgent and timely science cases

Enable frontier science in new regions and parameter regimes



EuPRAXIA is an ESFRI Distributed Facility





EuPRAXIA: Baseline Laser Design



The current EuPRAXIA laser design relies on Titanium Sapphire technology to address average (10 kW) and peak (PW) power as required by the project (1-5GeV LWFA).



L.A. Gizzi, et al., A viable laser driver for a user plasma accelerator, NIMA 909, 58 (2018); https://doi.org/10.1063/1.4984906
R. Assmann et al., EuPRAXIA Conceptual Design Report, The European Physical Journal Special Topics 229, 3675–4284 (2020); https://doi.org/10.1140/epist/e2020-000127-8
Water cooled Ti:Sa amplifier under development at ELI-HU (After V. Cvhykov *et al.*, Opt. Lett, 41, 3017, 2016)
Fluid (D2O) cooled Nd:YAG laser, 20 kW CW pump power, D2O (After X. Fu *et al.*, Opt. Express, 22, 18421 (2014)
Fluid (Siloxane) cooled Nd:YLF laser, 5 kW CW pump power (After Z. Ye *et al.*, Opt. Express, 24, 1758 (2016)

Advanced Photon Source





- Requirements on energy, pulse duration, stability etc set by the LPA working point
- Design based on CPA in Ti:Sapphire, dictated by requirements vs. time scale
- Thermal management issues to be addressed by means of liquid cooling
- Main developments required:
 - Prototyping of Ti:Sa amplifiers: fluid cooling: pilot studies
 - Addressing 100 Hz pump lasers developments
 - Thermal management of compressor gratings
 - Stability (pointing & more) and active control
 - Driver pulse temporal shaping and synchronization
- Construction
- Integration Issues



Underpinning EuPRAXIA-like Laser driver TDR





Diode laser pump challenge: viable 100 Hz

Diode lasers source of all optical power in EuPRAXIA

Challenge: 100 Hz pump supply





Preparatory review with Industry Berlin, held 5 October 2022 "Berlin Laser Tech Symposium" <u>Large industry</u>: Coherent, Leonardo, Lumibird, Jenoptik, Hamamatsu, <u>High-tech SMU</u>: Lastronics Research: CNR (L. Gizzi). Chair: FBH Berlin (P. Crump)

Consensus: Economic high duty cycle diode laser pumps remain extremely challenging Improved packaging and diodes and their reliability assurance strongly demanded



Diode specifications: known and open issues

Diode pump laser technical specs

- 20...100 Hz
- ~ 80 cm² square flat-top beam, imaged into amplifier, with up to several meters offset
- < 6° divergence angle, high polarization purity
- Multiple 500 kW units needed for largest system
- Yb:YAG: λ = 940 nm, ~ 500 µs pulses (5% duty cycle) high duty cycle packaging needed
- Nd:YAG: λ = 800 nm, ~ 200 µs pulses (2% duty cycle) higher power diodes needed

Key open topics:

- Lifetime requirements (uptime, system size, replacement rates / failure rate)
- Costs (purchase, maintenance, operation)
- Efficiency (energy cost of operation)
- Specifications / requirements for alternative wavelengths

Needed diode laser pump development goals and research efforts (3 y technology, 3 y qualification)

- Improved diode laser performance: higher efficiency, higher power
- Improved packaging: high performance economical cooling
- Cost reduction: higher power (\in /W), yield (\in)
- Prototyping of new concepts (e.g 780 nm or 1600 nm for Thulium)
- Reliability assurance (low failure rate)
- Security of supply: standardization, assurance of supply chain; European supply



Coherent Combination

Coherent combination has been proposed for Ti:Sa beamlets, in a similar approach as fiber combination, but with tiled-aperture.



Z. Li, et al., Laser Photonics Rev.2023,17, 210070

- Significant engineering issues to be overcome, but in line with current active control approach
- Could relax constraints on heat load management of >kW beamline and need of large optics
- Needs CDR

Ongoing 100 Hz developments



Intermediate milestone



EuPRAXIA

- PW class,
- 100 Hz repetition rate,
- multi kW average power,
- diode pumped
- Full therma load transport



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Eupraxia laser development is aimed at delivering more efficient, kW-PW laser driver for plasma acceleration at >100 Hz rate



CAPS.

- 30 TW peak power
- 100 Hz repetition rate
- 100 W average power
- Diode pumped
- Thermal load effects

- CURRENT
- PW class,

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- Hz repetition rate,
- ≈10 W average power
- flashlamp pumped
- No thermal load transport

100 Hz, J-scale laser beamline





Joule scale / 100 Hz / > 100 W

100 Hz beamline upgrade at ILIL



UPGRADE OF ILIL FACILITY FOR:

- 1. Upgrade of existing laser system (240 TW) for enhanced stability and control
- 2. New laser systems for high repetition rate operation (100 Hz-1J, 1kHz-20 mJ)
- 3. New Infrastructure development for user access to beamlines





User Infrastructure Upgrade



- EuPRAXIA Advanced Photon Sources (EUAPS) project (NG-EU, INFN-CNR-UTV)
- Photonics and Quantum Science (IPHOQS) project (NG-EU, CNR, POLIMI, LENS)



EUAPS WP2: High average power, high repetition rate laser beamline: 4.8 M€ IPHOQS A3.6 Ultrafast, high repetition rate radiation beamlines: 1.4 M€ IPHOQS A3.5: High Intensity, extreme laser beamlines: 1.5 M€





New High Repetition Rate Target Area



Funded by the European Union NextGenerationEU









kHz laser driver development for LPA

Roadmap on LPA Laser Driver technology

Laser-driven plasma acceleration needs ultrashort, high power lasers with high average power

- Current technology: ≈ Ti:Sa technology, pumped by flashlamp pumped lasers
 - · Robust, reliable industrial technology
- Mature technology: ≈ Ti:Sa technology, pumped by diodepumped lasers
 - Strong R&D effort in place (e.g HAPLS@ELI)
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 - A strategy is needed to steer effort in the LPA laser driver direction: LASPLA

[1] R. Assmann et al., EuPRAXIA Conceptual Design Report, The European Physical Journal Special Topics **229**, 3675–4284 (2020) [2] C. Danson et al., Petawatt and exawatt class lasers worldwide High Power Laser Sci. and Eng. **7**, e54 (2019)





The L3-HAPLS at ELI Beamlines Research Center in the Czech Republic. Credit: ELI Beamlines*

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Efficiency path

TiSa technology is prompt and will demonstrate repetitive operation 24/7 and stability, but not scalable with poor efficiency (% level) due to the indirect pumping architecture:

Direct CPA is a solution for wall-plug (WP) efficiency and high rep-rate.



We need a **gain medium** that can support amplification on a large bandwidth, has a **low quantum defect** and can be pumped **directly** with diode lasers: **endless quest for the perfect laser medium!!**

Several options under development

Fiber laser technology targeting the best WPE 30% in CW mode and coherent combination is being developed (FSU Jena-Fraunhofer IOF and Ecole Polytechnique-Thales in France).

Suited for moderate energy per pulse/high rep-rate (10s of kHz);

Now 96 fibers delivering 23 mJ and 674 W in a 235 fs pulse

Direct Chirped Pulse Amplification with lasing media pumped directly by diodes is ideal for higher efficiency and higher rep-rate;

several materials under consideration, Yb:CaF2, Tm:YLF, Tm:Lu2O3 (with cross-relaxation and multi-pulse extraction) ...

PENELOPE (Jena) 150 J, 1 Hz, at 1030 nm

Available ps kW thin disk lasers using plasma modulation (Oxford²)

OPCPA optical parametric amplification within large-aperture lithium triborate (LBO) crystals;

ELI-Beamlines facility, L1 ALLEGRA (100 mJ at 1 kHz) and L2 AMOS (100 TW, 2 to 5 J between 10 and 50 Hz), and the Shenguang II Multi-PW beamline(SIOM, China) ...

Thin Disk ps Lasers + spectral broadening + post compression³

Industrial technology with demonstrated >kW operation ar ≈J per pulse energy.

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L.A Gizzi, F. Mathieu, P. Mason, P P Rajeev, Laser drivers for Plasma Accelerators, in Félicie Albert et al, 2020 roadmap on plasma accelerators, 2021 New J. Phys. 23 031101, <u>https://doi.org/10.1088/1367-2630/abcc62;</u>

^{2.} O. Jakobsson, S. M. Hooker and R. Walczak, PRL, (2021)

^{3.} A.L. Viotti et al., Optica 9, 197-216 (2022).

Thulium based gain materials: Tm:YLF

Currently under investigation(*): Tm:YLF

- Emission at 1,9 µm, eye safe;
- Ultrashort pulse (<100 fs);
- High peak power \approx PW;
- High average power(scalable from kW to 300 kW);
- Direct pumping at 808 nm, using diodes operating in CW mode (available and scalable);
- Multi-pulse extraction at high repetition rate
- 10 kHz; Ideal for accelerator technology;
- High efficiency;
- Mature material technology (crystal growth);

C. Haefner et al., EAAC 2017



Tm: YLF Full specifications

Absorption peak wavelength 792 nm 0.55 × 10-20 cm2 Absorption cross-section at peak Absorption bandwidth at peak wavelenath 16 nm Laser wavelength 1900 nm Lifetime of 3F4 thulium energy level 16 ms Emission cross-section @1900 nm 0.4×10-20 cm2 Refractive index @1064 nm no=1.448. ne=1.470 Crystal structure tetraaonal Density 3.95 g/cm3 Mohs' hardness 5 Thermal conductivity 6 Wm-1K-1 dn/dT -4.6×10-6 (//c) K-1 Thermal expansion coefficient 10.1 × 10-6 (//c) K-1 Typical doping level 2-4 at.%

High Efficiency enabled by multipulse extraction (energy storage) Relatively new approach for short pulse operation: needs R&D, but promising

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Recent advances with Tm:YLF

Energy density storage and extraction capabilities of Diode pumped Tm:YLF (narrowband)





Amplified pulse energy measurements up to **108.3 J** for the 6-pass Tm:YLF power amplifier



- "The multiple proof-of-principle demonstrations [..] reveal the potential for high efficiency, high energy density extraction using Tm:YLF for future high peak and average power laser systems."
- "Additional efforts are currently in progress to conduct chirped pulse amplification of ultrashort pulses using Tm:YLF at the joule-level for the first time."

Issa Tamer, et al., "High energy operation of a diode-pumped Tm:YLF laser," Proc. SPIE 12401, High Power Lasers for Fusion Research VII, 1240109 (14 March 2023); doi:10.1117/12.2649103

Laser grade ceramic option

- Faster and cheaper vs. single crystal growth process for cubic crystalline structure.
- Large components, -shaping, -graded doping also optimized for thermal management **features not** available for single crystals.
- Several compositions (e.g. YAG, LuAG, Sc₂O₃, Lu₂O₃) and dopants (Nd, Yb, Er, Tm...) already available
- Spectroscopic and thermomechanical properties similar to those of the corresponding single crystals
- Better uniformity of dopant distribution on large gain elements

Industrial and R&D effort: (Japan); Research in China, Japan, Russia, USA, France and Italy (ISTEC-CNR) (ZENITH Smart Polycrystals)



Ceramic option: Tm in sesquioxide host

Sesquioxides doped with Tm3+, such as Tm:Lu2O3, Tm:Y2O3, and Tm:Sc2O3, are also emerging materials: their better thermo-optical properties make them promising for power scaling applications.

The growth of sesquioxide single crystals is very complicated, while it is possible to produce them in transparent ceramic form thanks to their cubic crystalline structure and optical isotropy.

Advantages of ceramic medium:

High thermal and mechanical features Scalable size Custom doping Optimize energy efficiency Best "hosts" for Thulium:

- yttrium lithium fluoride (YLF),
- yttrium aluminum garnet (YAG)
- Lutetium oxide (Lu₂O₃)



Sample from Konoshima

www.ino.it

C. Krankel, IEEE J. Sel. Topics Quantum Electro 21, Art. no. 1602013 (2015)

Ceramic option: Tm Lu₂O₃

Laser material: Tm:Lu₂O₃

- Emission at 2 µm;
- Large amplification bandwith
- Direct pumping at 800 nm, using diodes operating in CW mode (available and scalable);
- Cross relaxation partially compensates quantum defect option of in-band pumping.
- Multi-pulse extraction at high repetition rate > 10 kHz; Ideal for accelerator technology;
- Mature material technology (large ceramic).

	laser host material	laser host o _{abs} material (10 ⁻²¹ cm ²) YAG 7.5		λ_{em} (nm)	σ_{em} (10-21 cm ²)		λ _{th} (W m ⁻¹ K ⁻¹)	τ (ms)	reference	
Ī	YAG			2013		1.8	13	10	Heine, 1995	
	YLF	σ pol 3.6 π pol 8.0		1910 1880		2.35 3.7	6	15.6	Payne et al., 1992 Walsh et al., 1998	
	Lu ₂ O ₃	3.8		2070 1945) 2.3 5 8.5		13	3.8	Koopmann et al., 2009a	
_					_					
	laser host	λ_p	, λ _{em} (n) (nm) μ		¢	cw output slope ef		reference		
L	material	(nm)			p	oower (W)	(%)		reference	
	YAG	805	2	2013		115	52	Honea et al., 1997		
Γ	YAG	800	2	2013		120		LISA laser products OHG *		
Γ	YLF	792	1	1910 1912		55	49	Schellhorn, 2008 Schellhorn et al., 2009		
[YLF	790	1			148	32.6			
C	Lu_2O_3	796	2	070		1.5	61	Koopmann et al., 2009a		

[Scholle et al., 2010]



Commercial diode lasers

Tm:Lu₂O₃ Ceramic

Test platform for slope efficiency

An oscillator cavity has been set up for Tm:Lu₂O₃ gain material characterization



kHz laser development at ILIL

A kW-kHz CPA laser development with direct diode pumping



Main development effort in amplifier modules: ELI_{IT}/APOLLO project (CNR)

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Gain medium design and pumping

Side/edge pumped thin disk active mirror configuration [1,2]



J. Vetrovec, et al., "Wide-Bandwidth Ceramic Tm:Lu2O3 Amplifier", Proc. SPIE 9834, 983407 (2016); <u>https://doi.org/10.1117/12.2224411</u>
 J. Vetrovec, et al., "2-micron lasing in Tm:Lu2O3 ceramic:initial operation", Proc. SPIE 10511, 1051103 (2018); <u>https://doi.org/10.1117/12.2291380</u>
 D. Palla, L. Labate, F. Baffigi, G. Cellamare, L.A. Gizzi, Optics & Laser Technology, **156**, 108524 (2022), <u>https://doi.org/10.1016/j.optlastec.2022.108524</u>



Higher wpe: In-band pumping for low qd

Thulium based gain medium can also be pumped with in-band absorption with virtually marginal quantum defect: High efficiency and lower heat deposition.





30, 44270-44282 (2022)

New path for intra-band pumping and marginal quantum defect: step change in wpe?

cm⁻¹

efficie

1635

Summary

Grand challenges of laser-plasma technologies (including collider) are **limited by laser technology** and cost;

LWFA accelerators require industrial-strength PW-kW laser system, **beyond current state-of-the-art**;

Industry delivering PW systems now entering development of kW regime with higher efficiency (≈% level) with diode pumping of Ti:Sa based systems;

Short term **medical and industrial applications** are now mature and can motivate industrial investments;

Future large-scale needs >1 kW average power, already under development, aiming at >20% WP efficiency;

DPSSL with new materials (Tm:XX) among possible high efficiency solutions, scalable at high average power and high repetition rate;

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Infrastructure development and operation a major thrust for laser R&D and TRL

Thank you

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L.A. Gizzi, 24 Mar 2023, Alegro Workshop, DESY, Hamburg, Germany

CNR-INO

project

Intense Laser Irradiation Lab Pisa, Italy

A node of the Italian ELI Network A founding member of the EuPRAXIA infrastructure



Intense Laser Irradiation Laboratory

Istituto Nazionale di Ottica – Consiglio Nazionale delle Ricerche



INTENSE LASER IRRADIATION LABORATORY

CNR, Pisa, Italy

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